



INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)

25,775 USA

Application Number

10/087,036

Applicant(s)

K. Egawa et al.

Filing Date

02/28/2002

Group Art Unit

3834

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
TL	AL	55-125069	09/26/1980	Japan (with English Abstract	H02K	23/54		✓
	AM							
	AN							
	AO							
	AP							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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EXAMINER

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DATE CONSIDERED

5/15/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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INFORMATION DISCLOSURE CITATION
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AUG 11 2003

PATENT & TRADEMARK OFFICE

Docket Number (Optional) 25775 USA	Application Number 10/087,036
Applicant(s) K. Egawa et al.	
Filing Date 02/28/2002	Group Art Unit 2834

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FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
TZ	AL	JP10341562	1998-12-22	JAPAN (English Abstract)	H02K	23/00		✓
I	AM	JP2001275327	2001-10-05	JAPAN (English Abstract)	H02K	23/26		✓
I	AN	JP60128840	1985-07-09	JAPAN (English Abstract)	H02K	01/24		✓
TZ	AO	63 - 187545	1988-12-01	JAPAN	H02K	1/18		✓
	AP							

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

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EXAMINER <i>Thanh Lam</i>	DATE CONSIDERED <i>5/15/04</i>
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Applicant(s)

K. Egawa

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10/08/03

02/28/02

U.S. PATENT DOCUMENTS

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	AA						
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	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
TL	AL	09-46941	14.02.1997	Japan (English Abstract)	H02K	1/18		✓
	AM	10-174403	26.06.1998	Japan (English Abstract)	H02K	23/32		✓
I	AN	11-252843	17.09.1999	Japan (English Abstract)	H02K	3/18		✓
TL	AO	11-341755	10.12.1999	Japan (English Abstract)	H02K	15/09		✓
TL	AP	55-147964	18.11.1980	Japan (English Abstract)	H02K	23/58		✓

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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